

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chang, *et al.* Docket No.: TSM02-0658
Serial No.: 10/792,084 Art Unit: 1756
Filed: March 3, 2004 Examiner: Stephen D. Rosasco
For: Holographic Reticle and Patterning Method

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed May 24, 2007. Please amend the above-referenced application as follows.